

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re patent application of**

Sang-Hyuck AHN, et al.

**Attorney Docket No:** 6161.0013.AA

**Serial No.:** To Be Assigned

**Group Art Unit:** TBD

**Filed:** Concurrently Herewith

**Examiner:** TBD

**For:** METHOD FOR FABRICATING FIELD EMISSION DISPLAY WITH CARBON-BASED EMITTER

Assistant Commissioner of Patents  
Washington, D.C. 20231

Jc857 U.S. PTO  
10/08/741  
03/05/02



#3  
D. Scott  
8-10-02

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents, listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. A copy of the listed documents is provided herewith for the convenience of the Examiner.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to attorney's deposit account no. 23-1951.

Respectfully submitted,



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